



## APPLICATION DATA SHEET (ADS)

### APPLICATION INFORMATION

Application Type:: Regular  
Subject Matter:: Utility  
Title:: ELECTRON BEAM APPARATUS HAVING  
ELECTRON ANALYZER AND METHOD  
OF CONTROLLING LENSES  
  
Attorney Docket Number:: 116-040128  
Request for Early Publication?:: No  
Request for Non-Publication?:: No  
Suggested Drawing Figure:: 8  
Total Drawing Sheets:: 7  
Small Entity?:: No  
Secrecy Order In Parent Appl.?:: No

### APPLICANT INFORMATION

Applicant Authority Type:: Inventor  
Primary Citizenship Country:: Japan  
Status:: Full Capacity  
Given Name:: Toshikatsu  
Middle Name::  
Family Name:: Kaneyama  
Name Suffix::  
State or Prov. of Residence:: Tokyo  
Country of Residence:: Japan  
Street of Mailing Address:: 1-1, Ogawahigashi 2-chome  
  
City of Mailing Address:: Akiruno  
State or Prov. of Mailing Address:: Tokyo  
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### CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 28289

**REPRESENTATIVE INFORMATION**

<b>Representative Customer Number::</b>	28289	
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**FOREIGN PRIORITY INFORMATION**

<b>Country::</b>	<b>Application number::</b>	<b>Filing Date::</b>	<b>Priority Claimed::</b>
Japan	2003-14751	January 23, 2003	Yes

**ASSIGNMENT INFORMATION**

Assignee Name:: JEOL Ltd.  
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Country of Mailing Address:: Japan  
Postal or Zip Code:: 196-8448